IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

(Case No. 207.008-US)

In the Application of: Lutz et al.

Serial No: 10/627,237

Filed: July 25, 2003

Title: Anchors for Microelectromechanical Systems

Having an SOI Substrate, and Method for

Fabricating Same

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Group Art Unit: 2822

Examiner: Prenty, Mark V.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on *March 3, 2005*

(person signing this certificate)

SIXTH INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Submitted herewith are two (2) sheets of a modified Form PTO-1449. Electronic copies of the U.S. patents and published U.S. patent applications identified on the attached Form PTO-1449 are found on the attached compact disc ("CD"). A paper copy of each foreign document and publication cited on the attached Form PTO-1449 is also submitted.

Notably, U.S. Published Patent Application 2004-0065932 is the U.S. counterpart of International Application No. WO 01/46066, both of which are identified in the attached Form PTO-1449. That published application was cited in U.S. Patent Application Serial No. 10/455,555, entitled "Microelectromechanical Systems having Trench Isolated Contacts, and Methods for Fabricating Same".

It is respectfully requested that the Examiner make his/her consideration of these documents formally of record with the next Office Action.

Respectfully submitted,

Neil A. Steinberg, Reg. No. 34,735

Telephone No. 650-968-8079

Date: March 3, 2005

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N-21 (c, #		Sheet 1 of 2
PTO 19(ff (Modified)	ATTY. DOCKET NO.	SERIAL NUMBER
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	207.008-US	10/627,237
	APPLICANT(S)	
	Lutz et al.	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	FILING DATE	GROUP ART UNIT
	July 25, 2003	2822

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	4,849,071	7/1989	Evans et al.			
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FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO	
							-

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	

EXAMINER	DATE CONSIDERED

EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.

Sheet 2 of 2

DTG 1440 (M. 115.4)			ATTY. DOCKET NO. SERIAL NUMBER					
PTO-1449 (Modified) U.S. DEPARTMENT OF COMMERCE				207.008-US		10/627,23	37	
	PARTMENT OF COM TAND TRADEMARK		APPLI	CANT(S) Lutz et al.				
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			FILIN	G DATE July 25, 2003	GROUP	GROUP ART UNIT 2822		
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EXAMINER INITIALS	DOCUMENT NUMBER	DATE	J. TATE	NAME	CLASS	SUB CLASS	FILING DATE	
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		FOR	EIGN PAT	ENT DOCUMENTS				
EXAMINER INITIALS	DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO	
	WO 01/46066	6/2001		PCT				
	GB 2 198 611	6/1988		Great Britain				
- -	WO 97/49475	12/1997		PCT				
	EP 0 451 992	10/1991		European				
		-		Author, Title, Date, Pertino				
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	"Laterally Grown Anderson et al., 1			Silicon: A New Materia	I for Transduce	er Applicat	ions",	
EXAMINER				DATE CONSIDERED				
EXAMINER: I	Initial citation if refere	nce was conside with next com	red. Draw nunication	line through citation if not to applicant.	in conformance t	o MPEP 609	and not	